

Notice of References Cited	Application/Control No. 10/707,625	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Paulos M. Natnael	Art Unit 2622	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,833,880	12-2004	Chen, Luan Chi	348/787
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*	E	US-7,050,123	05-2006	Liu et al.	348/787
*	F	US-5,521,659	05-1996	Arnott, John	353/119
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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